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PATENT

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Inventor: Kenneth C. Johnson

Application No.: 10/611,298

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For: REDUCED MULTICUBIC DATABASE  
INTERPOLATION METHOD FOR  
OPTICAL MEASUREMENT OF  
DIFFRACTIVE MICROSTRUCTURES

Confirmation No.: 5587

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Examiner: Unknown

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Alexandria, VA 22313-1450**CERTIFICATE OF MAILING**I hereby certify that this correspondence is being deposited  
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